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## \*BIBDATASHEET\*

Bib Data Sheet

CONFIRMATION NO. 71

SERIAL NUMBER 10/619,918	FILING DATE 07/15/2003  RULE	CLASS 438	GROUP ART UNIT 2827	ATTORNEY DCKE NO. 2269-4212.6US (99 0306.06
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CON of 10/074,840 02/13/2002 PAT 6,593,171  
 which is a DIV of 09/640,801 08/17/2000 PAT 6,432,752

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

NONE

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 10/15/2003

Foreign Priority claimed

☐ yes ☒ no

35 USC 119 (a-d) conditions met

☐ yes ☒ no

Met after Allowance

Verified and Acknowledged

Examiner's Signature

Initials

STATE OR

COUNTRY  
ID

SHEETS

DRAWING  
9

TOTAL

CLAIMS  
27

INDEPENDENT

CLAIMS  
1

## ADDRESS

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## TITLE

Stereolithographic methods for fabricating hermetic semiconductor device packages and semiconductor devices including  
 stereolithographically fabricated hermetic packages

FILING FEE

 RECEIVED  
 876

FEES: Authority has been given in Paper  
 No. \_\_\_\_\_ to charge/credit DEPOSIT ACCOUNT  
 No. \_\_\_\_\_ for following:

☐ All Fees☐ 1.16 Fees ( Filing )☐ 1.17 Fees ( Processing Ext. of time☐ 1.18 Fees ( Issue )☐ Other \_\_\_\_\_☐ Credit